

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/905,286  
 Filing Date .... July 13, 2001  
 Inventor .... Cem Basceri et al.  
 Assignee .... Micron Technology, Inc.  
 Group Art Unit .... 1762  
 Examiner .... Eric B. Fuller  
 Attorney Docket No. .... MI22-1724  
 Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate  
 Comprising Dielectric Layers

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. A copy of the document listed on the accompanying PTO-1449 is enclosed. No admission is made regarding whether all the submitted reference is prior art.

Respectfully submitted,

Dated: 2-19-02

By:   
 Mark S. Matkin  
 Reg. No. 32,268

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